PTO/SB/08A (08-03)

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 4

Complete if Known	
Application Number	09/605,520
Filing Date	June 27, 2000
First Named Inventor	Marc A. Unger
Art Unit	1763
Examiner Name	Allan W. Olsen
Attorney Docket Number	20174C-000230US

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Document Number Number Kind Code[2] (*if known*)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
AWO	A1	US-4,992,312	02-12-1991	Frisch	
	A2	US-5,788,468	08-04-1998	Dewa et al.	
	A3	US-6,409,832 B2	06-25-2002	Weigl et al.	
AWO	A4	US-6,767,706 B2	07-27-2004	Quake et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Foreign Patent Document Country Code[3]	Number[4]	Kind Code[5] (*if known*)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T[6]
AWO	B1	WO	99/00655	A2	01-07-1999	Immunetics		☐
	B2	WO	99/04361	A1	01-28-1999	Diversified Scientific, Inc.		☐
	B3	WO	99/52633	A1	10-21-1999	Lumenal Technologies, L.P.		☐
	B4	WO	00/00678	A1	01-06-2000	University Of Washington		☐
	B5	WO	00/43748	A1	07-27-2000	YSI Incorporated		☐
	B6	WO	01/09595	A2	02-08-2001	Emerald Biostructures, Inc.		☐
AWO	B7	WO	01/09595	A3	02-08-2001	Emerald Biostructures, Inc.		☐

Examiner Signature	Allan Olsen	Date Considered	2-14-06

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AWO	C1	"Biochips," Nature Biotechnology, Vol. 18, Supplement 2000, pp. IT43-IT44, 2000	
	C2	"Chapter 9: Microfluidic Devices," Micromachined Transducers Sourcebook, pp. 779-882, 1998	
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	C16	GUÉRIN, L. J. et al., "Simple And Low Cost Fabrication Of Embedded Micro-Channels By Using A New Thick-Film Photoplastic," Transducers '97, 1997 International Conference on Solid-State Sensors and Actuators, Chicago, Illinois, pp. 1419-1422, 6/18-19/1997	
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